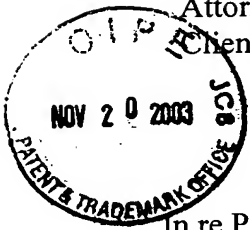


Attorney Docket: 061063-0306592

Client Reference: OSP-15151



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

HASEGAWA et al.

Appln. No. 10/696,702

Filed: October 30, 2003

Confirmation No.: Unassigned

Group Art Unit: 2823

Examiner: Estrada, Michelle

Title: SEMICONDUCTOR MANUFACTURING METHOD AND SEMICONDUCTOR
MANUFACTURING APPARATUS

* * * * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a PTO-1449.

The references were cited in the corresponding Japanese Patent Application No. 2000-108563 on which the parent application, 10/254,601, and grandparent application, 09/793,124, relies for priority under 35 U.S.C. §120. The Examiner is respectfully requested to consider each reference and return the PTO-1449 in accordance with MPEP §609 by initialing each reference and signing and dating the PTO-1449. Also enclosed is a copy of the Japanese Office Action dated October 28, 2003, along with an English translation. The Japanese Office Action is not more than three months prior to filing of the Information Disclosure Statement (IDS). The undersigned certifies that the references were first cited in the Japanese Office Action not more than three months prior to the filing of this IDS.

This IDS is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicants to comply fully.

This IDS is being submitted prior to the first Official Action on the merits, accordingly, no fee is due.

HASEGAWA et al. -- 10/696,702
Client/Matter: 061063-0306592

Consideration of the enclosed references and prompt and favorable examination on the merits are respectfully requested.

Respectfully submitted,

Pillsbury Winthrop LLP

By: 

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Tel. No.: (703) 905-2045

Fax No.: (703) 905-2500

Date: November 20, 2003

P.O. Box 10500
McLean, VA 22102
(703) 905-2000

Enclosures:

PTO-1449

Cited References

Japanese Office and English translation

JPD/tmt



Atty. Dkt. No.	M#	Client Ref.
	0306592	OSP15151

**INFORMATION DISCLOSURE STATEMENT
 BY APPLICANT**

Applicant: HASEGAWA et al.

Appln. No.: 10/696,702

Filing Date: October 30, 2003

Date: November 20, 2003

Page 1 of 1

Examiner: Estrada, M.

Group Art Unit: 2823

U.S. PATENT DOCUMENTS

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR					
	BR					
	CR					
	DR					
	ER					
	FR					
	GR					
	HR					
	IR					
	JR					
	KR					
	LR					
	MR					
	NR					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
	OR 10-144581	05/1998	Japan	Masanori		X			
	PR 60-145999	08/1985	Japan	Haruo		X			
	QR 6-61199	03/1994	Japan	Eiji		X			
	RR								
	SR								
	TR								
	UR								
	VR								
	WR								
	XR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	YR				
	ZR				
	AAR				
	BBR				
	CCR				
	DDR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.